



in 205-28-1

PATENT APPLICATION

AF  
LW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
SUNGHO JIN ET AL. )  
Application No.: 10/054499 )  
~~10/141,421~~ )  
Filed: 01/22/2002 )  
For: Optical Systems Comprising Curved )  
MEMs Mirrors and Methods for Making )  
Same )  
January 13, 2005

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Final Office Action mailed December 2, 2004, please amend  
the above-identified application as follows:

I hereby certify that this correspondence is being deposited  
with the United States Postal Service as first-class mail in an  
envelope addressed to: Commissioner for Patents, P.O. Box  
1450, Alexandria, VA 22313-1450 on

January 13, 2005

Date of Deposit

Glen E. Books

Glen E. Books

Signature

January 13, 2005  
Date of Signature